

Applicant(s)	Xingwu Wang et al.	INFORMATION DISCLOSURE STATEMENT
Serial No.	Unknown	
Filing Date	Herewith	
Group Art Unit	Unknown	
Examiner	Unknown	
Attorney Docket No.	125.021US02	
Title: MAGNETIC THIN FILM INDUCTORS		

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

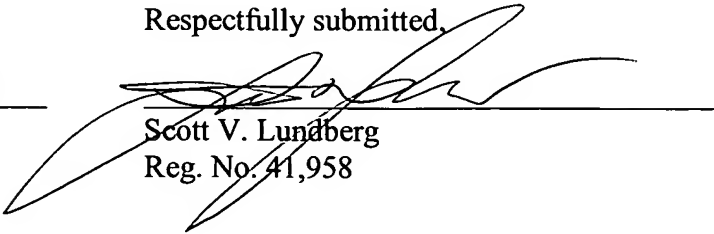
In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

Further pursuant to MPEP §609, because all of the references listed on the attached Form 1449 have been previously submitted and made of record in the parent application, U.S. Patent Application 10/014,045, filed December 11, 2001, copies of the references previously made of record in the parent application are not submitted herewith.

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

Date: 2-25-4


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Title: MAGNETIC THIN FILM INDUCTORS		Sheet 1 of 2

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	M. Yamaguchi, et al., Magnetic RF integrated thin-film inductors, IEEE MTT-S International Microwave Symposium Digest, Vol. 1, Pgs. 205-208 (2000).

Examiner Signature		Date Considered	
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			

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